

SEP 01 2005

PATENT

Attorney Docket No. MTI-31532

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Weimer, Ronald A.
Serial No.: 09/941,827
Filing Date: August 29, 2001
For: Method of Improved High K Dielectric-Polysilicon Interface for CMOS Devices
Examiner: HUYNH, Yennhu B.
Group Art Unit: 2813
Confirmation No.: 7551

CERTIFICATION UNDER 37 CFR 1.8(a) and 1.10

I hereby certify that, on the date shown below, this correspondence is being transmitted to Fax No. 571-273-8300 addressed to Examiner HUYNH at the US Patent and Trademark Office.

Date: 9-1-05 Risa Chandler

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

RESPONSE

Sir:

Applicant requests consideration of the pending claims in the above-identified patent application based on the remarks herein.

Amendments to the Claims begin on page 2 of this paper.

Remarks begin on page 29 of this paper.